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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Hiroshi TANAKA ) : Examiner: A. A. Mathews  
Application No.: 09/922,848 ) : Group Art Unit: 2851  
Filed: August 7, 2001 ) : Confirmation No.: 8629  
For: LIGHT RECEIVING APPARATUS, MARK ) : May 7, 2004  
DETECTING APPARATUS USING LIGHT ) :  
RECEIVING APPARATUS, EXPOSING ) :  
APPARATUS, MAINTENANCE METHOD OF ) :  
EXPOSING APPARATUS, MANUFACTURING ) :  
METHOD OF SEMICONDUCTOR DEVICE ) :  
USING EXPOSING APPARATUS AND ) :  
SEMICONDUCTOR MANUFACTURING PLANT:

**Mail Stop Issue Fee**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

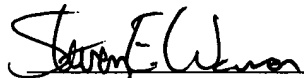
STATEMENT REGARDING SUBSTANCE OF THE INTERVIEW

Sir:

Applicant wishes to thank the Examiner for the courtesy extended toward his undersigned representative during the telephone conversation of April 2, 2004, which was reported in the Interview Summary Form attached to the Notice of Allowance dated April 9, 2004, in the above-identified application. The Examiner requested approval to cancel, by Examiner's Amendment, the claims directed to a non-elected invention, namely, claims 12-31 and 33-35. Applicant's representative approved this amendment to expedite allowance of this application.

Applicant's undersigned representative may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our below-listed address.

Respectfully submitted,

A handwritten signature in dark ink, appearing to read "Steven E. Warner", is written over a horizontal line.

Attorney for Applicant  
Steven E. Warner  
Registration No. 33,326

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